



INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449	Docket No. 52433/830	Application No. 10/561,133	
	Applicant(s) Natsuko SUGIURA, et al.	Examiner Deborah YEE	
	Filing Date December 15, 2005	Confirmation No. 6256	Art Unit 1793

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
/D.Y./	2001-064750	03/13/2001	JP	████████	████████	Abstract	
/D.Y./	98/32889	07/30/1998	PCT	████████	████████	Abstract	
/D.Y./	1246161	03/01/2000	CN	████████	████████	corresponding to WO 98/32889	

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
/D.Y./	Chinese Patent issued March 12, 2008 in corresponding Chinese Patent Application No.: CN 200480017463.3

EXAMINER	/Deborah Yee/	DATE CONSIDERED	09/12/2008
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			